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## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE (Attorney Docket No. 100176)

First Inventor: Roland K. Sevilla

Serial No.:

10/601,601

Filing Date:

06/23/2003

Title: POLISHING PAD FOR

**ELECTROCHEMICAL-**

MECHANICAL POLISHING

Examiner: Maurina T. Rachuba

Art Unit:

3723

## Certificate of Facsimile Transmission

I, Mariejose Monsalve, hereby certify that this paper and enclosure(s), if any, are hereby being transmitted by facsimile to the US Patent and Trademark Office's central fax No. (571) 273-8300 on 16 .) 1/ N

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Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

## **RESPONSE TO OFFICE ACTION**

This is a reply to the Office Action mailed June 7, 2006 for the above captioned U.S. patent application.

Amendments to the Claims are reflected in the listing of claims that begins on page 2 of this paper.

Remarks begin on page 4 of this paper.

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